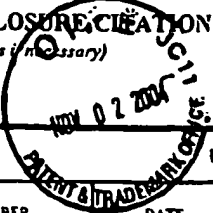


INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				Docket Number (Optional) YKI-0074		Application Number 09/965,937	
				Applicant(s) Katsuya Anzai et al.		Filing Date 09/28/2001	
				Group Art Unit 2674			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>Xu</i>		6,362,798	03/26/2002	Kimura et al.			

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<i>Xu</i>		2001/0040541	11/15/2001	Yoneda et al.			
<i>Xu</i>		2002/0070913	06/13/2002	Kimura et al.			
<i>Xu</i>		2003/0169218	09/11/2003	Kimura et al.			

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
<i>Xu</i>		JP 11-87720	1999.03.30	Japan				
<i>Xu</i>		JP 11-97701	1999.04.09	Japan				
<i>Xu</i>		JP 11-272233	1999.10.08	Japan				
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OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)
<i>Xu</i>		Office Action for Korean Patent Application No. 10-2001-0060955 dated July 21, 2004
<i>Xu</i>		Office Action for Korean Patent Application No. 10-2004-0029577 dated July 21, 2004

EXAMINER XIAO Wu	DATE CONSIDERED 11-23-04
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.